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Naoto Sano, ** CONTINUING Do ** FOREIGN APPL JAPAN 2000	gai, Tochigi, JAPAN; Tochigi, JAPAN; ATA ***********************************	nnanny 2				·		
Foreign Priority claimed 35 USC 119 (a-d) conditions			STATE OR COUNTRY JAPAN	SHEETS DRAWING 11		TOTAL CLAIMS 24		INDEPENDENT CLAIMS 6
ADDRESS 05514								
TITLE Laser oscillation apparatus, exposure apparatus, semiconductor device manufacturing method, semiconductor manufacturing factory, and exposure apparatus maintenance method								
FILING FEE FE	FILING FEE FEES: Authority has been given in Paper RECEIVED No to charge/credit DEPOSIT ACCOUNT				All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time) 1.18 Fees (Issue) Other Credit			